



IFW
Docket No.: P8375.0002
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Hidemitsu Aoki et al.

Patent No.: 6,890,391

10 680 216

Confirmation No.: 7422

Issued: May 10, 2005

Art Unit: 1746

For: METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE AND
APPARATUS FOR CLEANING
SUBSTRATE

Examiner: B. S. Carrillo

SUBMISSION OF INFORMATION DISCLOSURE STATEMENT (IDS)
AFTER ISSUANCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the cited reference be inserted into the file of the above-captioned patent. We acknowledge that the reference will not be considered, and that the reference will not be of record.

Dated: February 15, 2006

Respectfully submitted,

By

Michael J. Scheer

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PTO/SB/08a/b (07-05)

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Substitute for form 1449A/B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Complete if Known	
				Patent Number	6,890,391
				Issue Date	May 10, 2005
				First Named Inventor	Hidemitsu Aoki
				Application No.	10/680,216
				Examiner Name	B. S. Carrillo
Sheet	1	of	1	Attorney Docket Number	P8375.0002

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
	AA*	US-5,749,159	05-12-1998	Schwenkler	

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. * CITE NO.: Those application(s) which are marked with an single asterisk (*) next to the Cite No. are not supplied (under 37 CFR 1.98(a)(2)(iii)) because that application was filed after June 30, 2003 or is available in the IFW. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS			
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Examiner Signature		Date Considered	
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